



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Group Art Unit: 2814

Application No.: 08/930,449

Examiner: S. H. Rao

Filed: October 7, 1997

Docket No.: 039514

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE  
FILM AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

**AMENDMENT SUBMISSION UNDER 37 CFR §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 31, 2004 Final Office Action, and in view of the attached

Request for Continued Examination, please consider the following:

**Amendments to the Claims** are reflected in the listing of claims; and

**Remarks.**